IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Zhibo Zhang et al. Serial No.: To Be Assigned Filed: Concurrently Herewith

For: OPTOELECTRONIC DEVICES HAVING ARRAYS OF QUANTUM-DOT COMPOUND

SEMICONDUCTOR SUPERLATTICES THEREIN

Date: January 20, 2004

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a list of documents on form PTO-1449. Items 1-45 listed on the PTO-1449 were cited in parent application Serial No. 10/178,941, filed June 24, 2002. As the benefit of this application is claimed under 35 U.S.C. §120, no copies need to be furnished in accordance with 37 C.F.R. §1.98(d); however, copies will be furnished on request. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. §1.56 and Section 609 of the MPEP.

No fee is believed due. However, the Commissioner is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-0220. ■

Respectfully submitted.

Registration No. 36.92

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Candi L. Riggs

Substitute	form 1449A/PTO			Complete if Known		
				Application Number	To Be Assigned	
INFORM	IATION DISCL	.OSURE		Filing Date	Concurrently Herewith	
STATEMENT BY APPLICANT			•	First Named Inventor	Zhibo Zhang	-
017(120				Group Art Unit		
(use as ma	any sheets as nec	essary)		Examiner Name		
Sheet	1	of	2	Attorney Docket Number	5051-563DV	

Examiner Initials*	Cite No.	U.S. Patent Document		Name of Patentee or Applicant	Date of Publication of	Pages, Columns, Lines, Where Relevant Passages
		Number	Kind Code (if known)	of Cited Document	Cited Document MM-DD-YYYY	or Relevant Figures Appear
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Examiner Initials*	Cite No.	Foreign Patent Document		Name of Patentee or	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant	Т	
		Office	Number	Kind Code (if known)	Applicant of Cited Document	MM-DD-YYYY	Passages or Relevant Figures Appear	
	9.	EP	0 178 831	Bl	Alcan International Limited	08-07-1991		
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		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T
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Examiner Signature	Date Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Substitut	te form 1449A	/PTO		Complete if Known		
				Application Number	To Be Assigned	
INFOR	MATION D	ISCLOSUR	E	Filing Date	Concurrently Herewith	
STATEMENT BY APPLICANT				First Named Inventor	Zhibo Zhang	
			•	Group Art Unit		
(use as many sheets as necessary)				Examiner Name		
Sheet	2	of	2	Attorney Docket Number	5051-563DV	

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